

Step Source

비밀

License Agreement

This license agreement defines the relationship between Seldon Custom Plasmas of Milpitas, California and Chung Song Systems, Ltd. of Korea relating to the manufacture, use, and sales of plasma sources using intellectual property described in United States patent # 5,435,881, APPARATUS FOR PRODUCING PLANAR PLASMA USING VARYING MAGNETIC POLES.

Chung Song Systems, Ltd. desires to obtain nonexclusive rights to manufacture, use, and sell equipment including one or more plasma sources using principles described in this patent, and Seldon Custom Plasmas and John Seldon Ogle, the inventor of this patent and owner of these rights, desires to sell such nonexclusive rights to Chung Song Systems, Ltd.

The license agreement will be based on a unit license arrangement, where any plasma source using principles described by the patent/claims and manufactured, used, or sold by Chung Song Systems, Ltd. will have permanently attached a license label purchased from and authorized by an official of Seldon Custom Plasmas.

License labels authorized by Seldon Custom Plasmas will be made available without limit to either number or time, as long as this agreement is in effect. This agreement will be terminated under any of the following conditions:

- 1) When Patent protection under United States patent # 5,435,881 expires or is declared completely invalid by the United States Patent Office.
- 2) If Chung Song Systems, Ltd. intentionally manufactures, uses, or sells equipment including a plasma source which does not have a permanently attached license label purchased from Seldon Custom Plasmas and which uses principles described in the claims of this patent.
- 3) By mutual agreement between authorized officers of Seldon Custom Plasmas and Chung Song Systems, Ltd.
- 4) If Chung Song Systems, Ltd. intentionally assists any subsidiary or associate organization to manufacture, use, or sell equipment including a plasma source which does not have a permanently attached license label purchased from Seldon Custom Plasmas and which uses principles described in the claims of this patent.

The initial cost of each license label will be established at \$4000 in United States currency, which will include additional design support and consulting from Seldon Custom Plasmas personnel. The license label cost will be adjusted annually based on the cost of living increase in the United States as established by the United States Government.

John Seldon Ogle June 3, 1997